



Workshop "Advanced Mechanics in Accelerator Technology" (AMAT), 19 April 2013, CERN

Materials studies and tests at CERN

- Mandate and expertise
- Equipment
- Examples of material studies and tests
- Perspectives

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Home > Groups > MME > MM > - Mandate

Metallurgy and Metrology Sect

Undertakes the development, selection, specific control of materials and components including materials and components. Performs allure anal









Structure

films. Provides support for the quality chanical tests and measurements on

©CERN 2009



Microstructural characterization. Specimen preparation



Sectioning

Linear precision Saw. *Buehler IsoMet 4000* Precision diamond wire saws. *Well 3242 and 3241*

Mounting

Hot mounting presses. *Buehler Simplimet 1000 and 2000* Cold mounting pressure chamber. *LamPlan M.M. 806*

Grinding & polishing Manual polishing machines. *LamPlan M.M. 8027 S. and Plamopol 2* Automatic polishing machines. *Buehler Phoenix 4000 and LamPlan M.M. 8055* Vibratory polishing machine. *Buehler vibromet 2* Automatic electrolytic polishing-etching. *ATM Kristall 620 with electrolytic cell*









Morphology of a Nb coating on Cu structure, origina magnification 50000 x

200 nm

EHT = 5.00 kV WD = 2.9 mm Signal A = InLens Test 43 - Be3 - pt 4

HIE-ISOLDE cavity Nb coating on Cu



SE and BSE imaging detectors. Max resolution 4 nm Beam 0.5 to 30 kV, 1pA to 500 nA EDS analyser Oxford Isis.

FE-SEM. Zeiss Σigma

Chamber Ø365 mm x 275 mm SE, BSE, in-lens SE imaging detectors. Max resolution 1.5 nm Beam 0.1 to 30 kV, 4 pA to 20 nA EDS analysis Oxford Inca with 30 mm² SDD detector EBSD analysis HKL Chanel 5





n. Observation and analysis



Optical microscopy

Various stereo microscopes. Metallographic microscope. Leica DMRM Objectives for magnifications from x16 to x1500 Image analysis system Digital portable microscope. Keyence VHX-1000 **Resolution max 54 MPixel** Objectives 0 - x50, x20 - x200 and x100 - x1000



Spectroscopy and X ray diffraction

Powder XR diffraction. Siemens D5000 Cu and Cr X-ray sources Vertical and horizontal goniometers

New optical microscope being purchased in 2013

Portable OES analyser. Oxford Instruments PMI Master Pro Calibration New SEIM (replacement LEO) in 2015

UV probe for S and P



Scanning Electron Microscopy and microanalysis support



Carbon wires from SPS beam scan: region degraded by the beam (left) and unused reference (right, same scale)







Microstructural

 EHT = 20.00 kV
 Bi2212
 Mag = 2.50 K X

 VVD = 16.0 mm
 Processed
 Notherto-immenaz Mena Signal A = 5E2
 Date 63.00 2012

EN

2 µm

Bi2201

orientation map

inverse pole figure



Mechanical testing

100 kN cryostat for tensile testing and eventually fracture mechanics at 4.2 K in construction (2013)

Tensile testing machines

Two column electromechanical universal testing machine UTS 200 Load cells 1 kN, 20 kN and 200 kN, stroke 800 mm Knives and clip-on extensometers Tensile grips, compression plates, bending tools System for tests at 77 K and 4.2 K, 25 kN load cell

Single column press ZPM 1000-500. Load cell 1 kN, stroke 500 mm



New dynamic mechanical testing unit

in 2014





Hardness Hardness. Wolpert 2R Load 1 Brinell, Micro hardness autor Load 10





Mechanical testing at 4.2 K, the past...



2 - 3 - 4 - 5 - 6 - 7 - 8 - 9 - 10 - 11









Evolution of the equipment

Internal load cell: immersed in liquid He, based on a deformable 316LN ring equipped by strain gauges *conditioner:* MVD2555 of HMB



Temperature probe, CERNOX CX-1050-SD-30 (Lakeshore Cryotronics): *thermal response time:* 15 ms at 4 K *resolution:* ± 15 mK

Carbon potentiometer: *range:* up to 50 mm *resolution:* 0.1 mm

Evolution of the equipment

Stainless Steel 316LN - sample 1





5.2 Mechanical Testing

The mechanical properties of forgings supplied under this specification shall meet the properties required by ASTM A182, Grade FXM-19.

A182/A182M - 10a





Mechanical testing at 4.2 K, the present and future

2



CERN + CEME

Document: 060741-14 @ CEME: 2013

7 K of forged Nitronic 50 material and its welding



100



Present involvements



Non destructive testing

Visual testing, VT, two level 2 certified

Penetrant testing, PT, two level 2 certified



Ultrasonic testing, UT

Portable flaw detectors. *Krautkramer USN 60* Gain 0 dB to 110 dB, probe from 0.25 MHz to 25 MHz, Portable flaw detector with Phased Array mode. GE Phasor XS Gain 0 dB to 40 dB, probe from 0.5 MHz to 10 MHz, Various sectorial or linear transducers

Immersion tank scanner

Scan-surface: 500 mm x 500 mm, 0.1 MHz to 150 MHz Level 3 and 2 certified operators







Radiographic testing, RT Mobile X-ray computed tomogra Mini-focus x-ray s Flat panel detecto Software for 3D r X-ray sources. *Philips 160 kV*, 0. Sieffert isovolt 16 Computer radiography system High definition sc High resolution m Controlled area (bunker) of 30 m Level 2 certified operators







Non destructive testing





⇐ Computed Radiography Testing (RT) of LSS warm modules. Completion of the radiography campaigns during LHC technical stops. 1767 modules examined, 107 non-conformities identified to be repaired during LS_1, 46 nights.



 \Downarrow Computed RT of CMS RF modules









 $\Leftarrow Computed RT of ATLAS RF modules$







EN Engineering Department

Delivery and test description



- ITER CC He Inlets samples delivered to CERN by ASIPP in March 2013
- Two welded with buttering (B-L and B-S) and two without buttering (WB-L and WB-S)
- Laminography (planar tomography) of all four samples performed by RX Solutions /FR, allowing to access defects in the whole weld volume with higher resolution than through computed RT
- Classification following ISO 6520-1 and judged with respect to EN ISO 5817 level B



Laminography of WB-S sample

3D tomography Engineering Department Technique description





• Specimens placed on a mobile and rotatable stage

- Motorized zoom
- Full inspection of samples up to 240 mm length
- Sealed microfocus source, max. tension 150 kV
- HR area image sensor, 1920 pixels x 1536 pixels
- Detection surface: 200 mm x 250 mm
- 14 bits 16000 gray levels
- 1-30 images /s



2nd sample of the VPI

11 separate 360° scans were combined to compile a final single 3D object reconstruction while avoiding shadows due to steel conduits





Solution Solution

iter china eu india japan korea russia usa







a

b

Conclusions



- CERN-wide (and beyond) activity
- Limited but selected and highly specialized equipment
- Covers a wide range of materials, welds and components
- Provides support to CERN stores (specifications, identification of suppliers, audit...)
- Several decades of experience, including audit and follow-up of industrial production
- In house expertise completed by an extensive network
- Prone to intervene in or pilot activities with a strong emphasis on materials or controls
- Section very exposed to international exchanges and contacts:
 - Industrial partners
 - National labs, academy
 - CERN-ITER cooperation agreement (IO, DAs via IO)

- Training of students and fellows, hosted a large (3 digit) number of trainees since the creation of the section in the early 90ies